

Attorney Docket No.: 033773M064

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1096

Applicants : Toshiharu DAI, et al.  
Serial No. : 10/774,529  
Filed : February 10, 2004  
Examiner : Chuong A. Luu  
Group Art Unit : 2818  
For : SEMICONDUCTOR WAFER PROCESSING METHOD

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 26, 2006, please consider the following remarks.

This Request for Reconsideration is accompanied by a Petition for Extension of Time (One-Month) and a check for the sum of \$120, in payment of the extension fee.